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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

\*ppl. No. : 10/522,230

Applicant: Taeun PARK et al.Filed: January 24, 2005

TC/A.U. : 1618

Examiner : Jake Minh VU

Docket No. : 1751-367 Customer No. : 06449 Confirmation No. : 7022

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

## Dear Sir:

Under the provisions of 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant submits herewith information that the Office may wish to consider in examination of the subject application. Materials submitted for consideration are listed on the attached form PTO-1449.

I hereby certify that each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement. A copy of the European Search Report for EP 03 76 5386, mailed August 10, 2005 is enclosed.

No fee is required.

Respectfully submitted,

Ву

G. Franklin Rothwell

Attorney for Applicants Registration No. 18,125

ROTHWELL, FIGG, ERNST & MANBECK, p.c.

Suite 800, 1425 K Street, N.W.

Washington, D.C. 20005 Telephone: (202)783-6040

Enclosure(s): International Search Report

PTO-1449

						Complete if Known					
					А	pplicat	ion Number	10/522,230			
TP ENFORMATION DISCLOSURE STATEMENT BY APPLICANT						iling Da	ate	January 24, 2005			
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					E	xamine	er Name	Jake Minh Vu			
ABEN Sheet		1	of	1	Α	ttorney	Docket Number	1751-367			
					U.S	S. PAT	ENT DOCUMENTS	5			
Examiner Initials*	Cite No.1	U.S. Patent Document  Number Kind  (if ki				Gode <sup>2</sup> wn)	Name of Patentee or Applicant of Cited Document		Date of Publication of Cited Document MM-DD-YYYY		
	1	5,538,728					YANAKI et al.		07-23-1996		
	2	6,039,981					WOO et al.		03-21-2000		
				F	ORE	IGN P	ATENT DOCUMEN	NTS			
		Foreign Patent Docume				it					
Examiner Initials*	Cite No. <sup>1</sup>	l _						ee or Applicant of Cited ocument	Date of Publication of Cited Document MM-DD-YYYY	T <sup>6</sup>	
	3	WO 01/74356			A1	F. HOFFMAN-LA ROCHE AG		10-11-2001	1		
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Signature | Considered |
\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code. <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.